Near-Infrared Spectrometer

SM304







SM304

Near-Infrared (NIR) Spectrometer

User Selectable various NIR Ranges from 0.9 - 2.5 µm

Low Dark Noise and High Stability

Best Performance for NIR Spectroscopy

Wide dynamic range and high signal-to-noise ratio

Optical Dark Option (Auto Shutter)



The Choice for Low Signal Level NIR Applications

Spectral Products offers the new SM304 TE-cooled InGaAs/Extended-InGaAs array spectrometers. The SM304 series are ideal for NIR spectroscopic measurement that requires a very high signal-to-noise ratio and/or high dynamic range through the $0.9 - 2.5 \mu m$ spectral range.

The high performance with a low-noise level of the SM304 series makes it possible to apply in various demanding applications. The good sensitivity of the detectors used in the SM304 series allows various broad-band applications such as measuring the optical properties of solid/liquid/gas samples in the NIR range, analyzing chemical components, detecting moisture, and narrow bandwidth applications like NIR laser characterization.

The standard interface of the SM304 series is a USB interface with 16-bit AD conversion. Software support includes various SDK examples and DLLs for dedicated applications development and Windows OS-based spectral acquisition and analysis software (SM32Pro & SMProMX).





Specifications:

Feature	Value						
Models	SM304-512	SM304-512-2.2	SM304-512-2.5	SM304-256-2.1	SM304-256-2.5		
Detectors	G9204-512	G9206-512	G9208-512	G9206-256	G9208-256		
Pixel Size	25 X 500 μm	500 μm 25 X 250 μm 50 X			500 μm		
Spectrograph f-number	3.3						
Dark	Auto Shutter						
Dark Readout Noise RMS ¹ (w/single scan, no time averaging)	6 @100ms		16 @10ms	6 @100ms	8 @10ms		
Signal to Noise Ratio (SNR) ¹ (w/single scan, no time averaging) ²	>15,000 : 1		ns	>7,500 : 1 @ 10ms			
Spectral Response Range	0.9-1.7 μm	0.9-2.2 μm	0.9-2.5 μm	0.9-2.05 μm	0.9-2.5 μm		
Order Sorting Filter	Long-pass filter or linear variable filter installed according to wavelength coverage						
Optical Resolution (Max. with 25 um or 50 um slit)	>3 nm overall	>4.5 nm overall	>5.5 nm overall	>7.0 nm overall	>10.0 nm overall		
Stray Light	<0.01 % at 632 nm (<0.05 % Ave)						
Fiber Coupling	SMA905 or FC/PC standard						
Computer interface	USB 1.1/2.0 compatible						
Minimum integration time	1 msec						
Trigger Mode	Free Run Mode						
	Software Trigger Mode						
	External trigger mode (20-pin connector) : TTL Edge trigger input						
Power Input	DC 5V, 5A Max						
Dimensions	173 mm X 120 mm X 75 mm						
Weight	2.0 kg						
Software	SM32Pro / SMProMX						
	Includes DLL libraries and SDKs for user customized application development						

Resolution Chart:

1 : Measured with TEC ON & 10pF CF value

²: Max signal level at ~50,000 counts, using 5W tungsten-halogen light source (regulation: +/-0.4%)

Feature	Value						
Models	SM304-512	SM304-512-2.2	SM304-512-2.5	SM304-256-2.1	SM304-256-2.5		
Spectral Response Range	0.9-1.7 μm	0.9-2.2 μm	0.9-2.5 μm	0.9-2.05 μm	0.9-2. 5μm		
Slit Width (µm)	Max. Optical Resolution (FWHM, nm)						
25	3	4.5	5.5	-	-		
50	-	-	-	7.0	10.0		

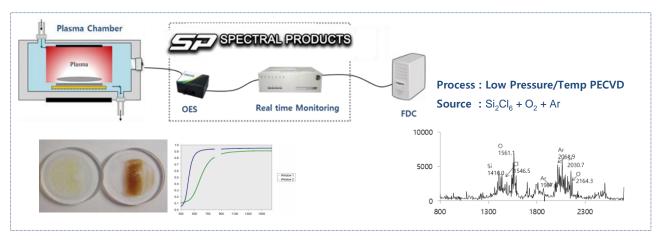
Note) Optical Resolution Value : Average



Applications

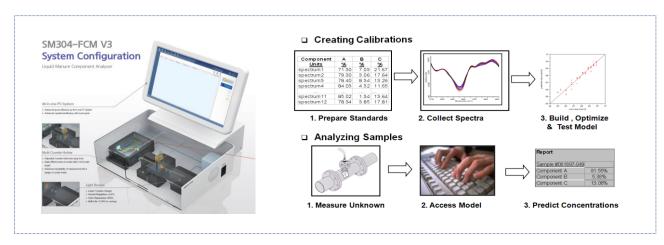
NIR OES Sensor for Plasma Diagnostics

- Long term usage resistant to view port pollution for plasma diagnostics in semiconductor fabrications
- Extended spectral range of OES(optical emission spectroscopy) sensor up to 2.5 μm



Real time NIR Spectrophotometer

- Real time measurements of transmission and absorption without mechanical grating rotation/scanning
- Analysis and optical monitoring of various solid/liquid/gas samples (Chemicals, Liquid Fertilizer, etc.)
- Customized calibration formula by use of signal processing, chemometrics, and statistical algorithms

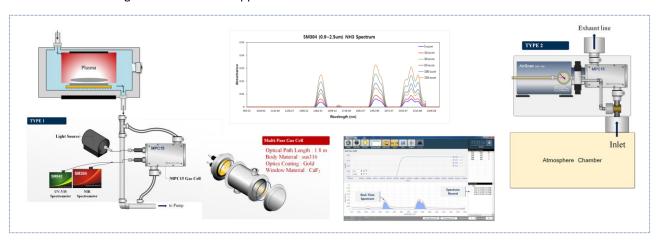






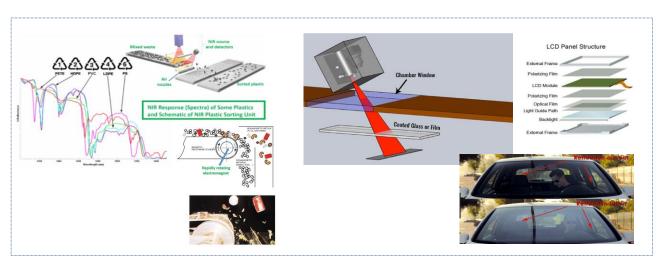
Optical Monitoring of Gas and Water Vapor

- In-Situ quantitative optical monitoring of vacuum / atmospheric gases and water vapor
- Customized configuration for various applications in laboratories and industrial factories



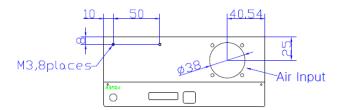
Analysis of optical & chemical properties of films and materials

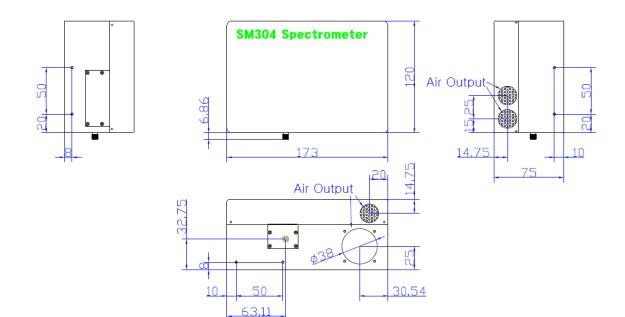
- Measurement of thickness and optical properties of high thickness films
- Measurement of reflectance and transmittance (absorbance) of various materials (plastic and film etc)





Case Dimension:





Ordering Information: Please indicate product number and description when ordering SM304 Near-Infrared Spectrometer

